

**Notice of References Cited**

Application/Control No.

10/814,697

Applicant(s)/Patent Under  
Reexamination  
SHI ET AL.

Examiner

Anna L. Verderame

Art Unit

1756

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**U.S. PATENT DOCUMENTS**

| * |   | Document Number<br>Country Code-Number-Kind Code | Date<br>MM-YYYY | Name         | Classification |
|---|---|--|-----------------|--------------|----------------|
| * | A | US-2004/0161575                                  | 08-2004         | Hwang et al. | 428/064.8      |
| * | B | US-2002/0154596                                  | 10-2002         | Hsu et al.   | 369/288        |
| * | C | US-2004/0079195                                  | 04-2004         | Perry et al. | 075/345        |
|   | D | US-  |                 |              |                |
|   | E | US-  |                 |              |                |
|   | F | US-  |                 |              |                |
|   | G | US-  |                 |              |                |
|   | H | US-  |                 |              |                |
|   | I | US-  |                 |              |                |
|   | J | US-  |                 |              |                |
|   | K | US-  |                 |              |                |
|   | L | US-  |                 |              |                |
|   | M | US-  |                 |              |                |

**FOREIGN PATENT DOCUMENTS**

| * |   | Document Number<br>Country Code-Number-Kind Code | Date<br>MM-YYYY | Country | Name          | Classification |
|---|---|--|-----------------|---------|---------------|----------------|
|   | N | WO 2004/029936                                   | 08-2004         | Korea   | Kim et al     |                |
|   | O | EP 0 580 346                                     | 07-1992         | EP      | Lida et al    |                |
|   | P | WO 02/48432                                      | 06-2002         | US      | Perry et al.  |                |
|   | Q | JP 2002-133720                                   | 05-2002         | Japan   | Nomura et al. |                |
|   | R |  |                 |         |               |                |
|   | S |  |                 |         |               |                |
|   | T |  |                 |         |               |                |

**NON-PATENT DOCUMENTS**

| * |   | Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)   |
|---|---|---|
|   | U | Sonnichsen et al. "Drastic Reduction of Plasmon Damping in Gold Nanorods" Physical Review Letters. Volume 88, Number 7, 2002.   |
|   | V | Nomura et al., "Super-resolution read only memory disk with metal nanoparticles or small aperture", Japanese Journal of Applied Physics. Pt 1. vol. 41(3B) pp. 1876-1879(March/2002).           |
|   | W | Fujii et al., "A near-field recording and readout technology using a metallic probe in an optical disk" Japanese Journal of Applied Physics Vol. 39 (2000) pp.980-981                           |
|   | X | Sun et al. "Increased sensitivity of Surface Plasmon Resonance of Gold Nanoshellss compared to that of Gold Solid Colloids in Response to Environmental Change" Anal. Chem, 2002, 74,5297-5305. |

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.